	IAP20 Rection 15 DEC 20									
APPLICANT'S ART CITATION (Use several sheets if necessary)				Application OFGS F1 10 1/285 6: 1/24 1 2						
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				Filing Date			Group Art Offic			
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)										
Examiner Initial	Document Number		Date MM-YYYY		Name	Class	Sub- class	Filing Date If Appropriate		
	US-5,443,944		08-1995		Krafft et al	430	529	, , , , , , , , , , , , , , , , , , ,		
FOREIGN PATENT DOCUMENTS										
	Document Number		Date MM-YYYY		Country	Class	Sub- class	Translation		
								Yes	No	
	JP 2004-212993		07-2004		Japan			abstract		
	JP 2004-175373		06-2004		Japan			abstract		
	JP 2002-265781		09-2002		Japan			abstract	-	
····	62-275137		11-1987		Japan			abstract		
	10-507225		07-1998		Japan				X	
	WO 96/22317		07-1996		WIPO			X		
	07-105718		04-1995		Japan			abstract		
	06-208198		07-1994		Japan			abstract		
	11-241021		09-1999		Japan		-	abstract		
	07-238149		09-1995		Japan			abstract		
	2003-037024		02-2003		Japan		ļ	abstract		
	63-158829		07-1988		Japan			abstract		
	63-173313		07-1988		Japan			abstract		
	11-074157		03-1999		Japan			abstract		
	2003-142168		05-2003		Japan			abstract		
,	2003-243681		08-2003		Japan			abstract		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)										
30000000000000000000000000000000000000	***********	International Search Report PCT/JP2004/00884 dated 23 August 2004								
Examiner	Examiner /Khanh Nguyen/				Date Considered 03/24/2009					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.										

DOCUMENTS FOR IDS

In order to fulfill the duty of disclosure, please file the enclosed thirteen documents, which are cited in the specification as constituting background art of the present invention, together with an IDS.

- Japanese Unexamined Patent Application, First Publication No. Sho 62-275137 (English Abstract)
- Published Japanese Translation No. Hei 10-507225 of the PCT Application (WO96/22317, International Publication date: September 15, 1995)
- Japanese Unexamined Patent Application, First Publication No. Hei 7-105718
 (English Abstract)
- Japanese Unexamined Patent Application, First Publication No. Hei 06-208198

 (English Abstract) (USP 5 4439 44 is a corresponding application thereof.)
- Japanese Unexamined Patent Application, First Publication No. Hei 11-241021 (English Abstract)
- Japanese Unexamined Patent Application, First Publication No. Hei 07-238149 (English Abstract)
- Japanese Patent No. 2546617
 (The aforementioned Japanese Unexamined Patent Application, First Publication No. Hei 07-238149 was patented, and was provided Patent Number 2546617.)
- Japanese Unexamined Patent Application, First Publication No. 2003-37024 (English Abstract)
- Japanese Unexamined Patent Application, First Publication No. Sho 63-158829
 (English Abstract)
- Japanese Unexamined Patent Application, First Publication No. Sho 63-173313
 (English Abstract)
- Japanese Unexamined Patent Application, First Publication No. Hei 11-74157 (English Abstract)
- Japanese Unexamined Patent Application, First Publication No. 2003-142168
 (English Abstract)
- Japanese Unexamined Patent Application, First Publication No. 2003-243681 (English Abstract)